

STRAY LIGHT Analysis and Control

Eric C. Fest



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Preface

In 1741, the great Swiss mathematician Leonhard Euler was asked by King Frederick the Great of Prussia to write a tutorial on natural philosophy and science for his niece, the Princess of Anhalt-Dessau. Euler agreed and began writing the tutorial as a series of letters to the Princess, about one a week, for nearly 250 weeks. These letters were eventually published as a collection and became some of the first popular science writing.¹



Portrait of Leonhard Euler, by Johann Georg Brucker (1756).

In a letter entitled "Precautions to be observed in the Construction of Telescopes"² (shown in the second figure), Euler recommends that the Princess

"... (enclose the telescope) in a tube, that no other rays, except those which are transmitted through the objective, may reach the other lenses... If by any accident the tube shall be perforated ever so slightly, the extraneous light would confound the representation of the object."

LETTER CVIII.

Precautions to be observed in the Construction of Telefcopes. Necessity of blackening the Instide of Tubes. Diaphragms.

A FTER these refearches respecting the construction of telescopes, I must suggest and explain certain precautions necessary to be used; which, though they relate neither to the lenses themselves, nor to their arrangement, are nevertheless of such importance, that if they are not very carefully obferved, the best instrument is rendered entirely useless. It is not sufficient that the lenses should be arranged in such a manner that all the rays which fall upon them shall be transmitted through these lenses to the eye; care must be taken, besides, to prevent Vol. II. Ff the the transmission of extraneous rays through the telefcope, to difturb the representation. Let the following precautions, then, be taken.

I. The lenfes, of which a telefcope is compofed, muft be inclofed in a tube, that no other rays, except thofe which are transmitted through the objective, may reach the other lenfes. For this effect, the tube muft be very clofe throughout, that not a chink admit the smallest portion of light. If by any accident the tube shall be perforated ever fo shightly, the extraneous light admitted would confound the reprefentation of the object.

II. It is likewife of importance to blacken, throughout, the infide of the telefcope, of the deepeft black pofible, as it is well known that this colour reflects not the rays of light, be they ever fo powerful. You must have observed, accordingly, that the tubes of telefcopes are always blackened internally. A fingle reflection will fhew the neceflity of it.



Excerpts from Leonhard Euler's tutorial. The figures show the telescope before and after the addition of field stops, which were added for stray light control.

He also suggests that she "[...] blacken, throughout, the inside of the telescope, of the deepest black possible, as it is well known that this colour reflects not the rays of light, be they ever so powerful".

Though he calls them "diaphragms" and not field stops, Euler goes on to suggest their use as a further means of "diminishing the unpleasant effect of which I have been speaking." This unpleasant effect is, of course, what we now call stray light, and this letter shows that it was identified as a problem hundreds of years ago. It is remarkable that the methods Euler discussed to control it (i.e., the use black surface treatments, field stops, and baffles) are still some of the primary methods used to control it today (see Chapters 6, 8, and 9, respectively). Of course, some things have changed; Euler and the Princess didn't have the massive computing power we have today, and therefore were unable to predict the stray light performance of a telescope to the accuracy that is now possible. In addition, the occurrence of stray light in their telescope was an "unpleasant effect" and was not as serious a

problem as, say, the loss of scientific data due to stray light in a multi-billion-dollar space-based telescope.

However, the letter shows that the problem and many of its solutions remain the same. The goal of Euler's letter and of this book are similar: to provide optical engineers with the information and analytical tools necessary to design and build optical systems with sufficient stray light control. In addition to Euler's letter, there have been hundreds of papers published on the subject, and it is impossible to include the content of all of them here. Therefore, only the content that is most applicable to the task of *optical system engineering* is discussed. This is an important distinction, as many previous publications deal with the science of optical scattering and stray light, but fewer address the application of this science in engineering practice. This book summarizes the important scientific results, providing references for more detailed study, and then applies these theories to the engineering of optical systems. This book also considers the economics of performing stray light analysis, which is a dimension that is also lacking in the current literature. Sometimes the engineer tasked with performing a stray light analysis has months of time and a large budget, and other times has 15 minutes and no budget. This book provides tools and solutions for a spectrum of budgets, and quantifies the accuracy associated with each approach.

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- 1. T. McGew (Ed.), Discussion of Euler's "Letters to a German Princess", http://homepages.wmich.edu/~mcgrew/euler.htm.
- 2. L. Euler and N. de Condorcet, *Letters of Euler to a German Princess, on Different Subjects in Physics and Philosophy, Volume 2*, H. Hunter, Trans., translated from the French and published by Murray and Highley (1802).

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This book is dedicated to my daughters, Fiona and Marlena.